Inventor Information

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Application Information

Title Line One::

STAGE APPARATUS, VIBRATION CONTROL

METHOD AND EXPOSURE APPARATUS

Title Line Two:: Total Drawing Sheets::

10 110975

Docket Number::

Prior Foreign Applications

Foreign Application One::

2000-393837

Filing Date::

December 25, 2000

Country::

Japan

Priority Claimed::

Yes

Foreign Application Two::

2000-393838

Filing Date::

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Country::

Japan

Priority Claimed::

Yes

Assignee Information

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